



17658

PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: SCHWAB ET AL -3
SERIAL NO.: 09/764,634 GROUP: 1765
FILED: JANUARY 18, 2001 EXAMINER: B.X. TRAN
TITLE: PROCESS FOR PRODUCING A SEMICONDUCTOR WAFER

SUBMISSION OF INFORMATION DISCLOSURE
STATEMENT OF DR. WOLFGANG STAUDACHER

Mail Stop Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the attached first Information Disclosure Statement, dated September 10, 2003, duly signed by Dr. Wolfgang Staudacher, and the three reference listed on the enclosed Form PTO-1449 and attached thereto, which are based upon the Japanese Office Action

Applicants wish to bring to the attention of the Patent Examiner the attached second Information Disclosure Statement, dated November 12, 2003, duly signed by Dr. Wolfgang Staudacher, and the three reference listed on the enclosed Form PTO-1449 and attached thereto, which are based upon the enclosed European Search Report.

12/15/2003 AADDF01 00000021 09764634

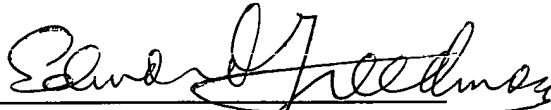
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180.00 OP

A check in the amount of \$180.00 is enclosed to cover the fee for filing this one Submission of two Information Disclosure Statements (IDS). The Commissioner is hereby authorized to charge Deposit Account No. 03-2468 for any additional fees or credit any overpayment in connection with this IDS. It is respectfully requested that the foregoing IDS be incorporated into the official file of the present patent application.

Respectfully submitted,

GUNTER SCHWAB ET AL



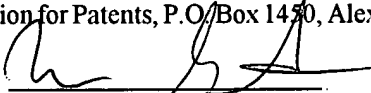
Allison C. Collard, Reg. No. 22,532
Edward R. Freedman, Reg. No. 26,048
Attorneys for Applicant

COLLARD & ROE, P.C.
1077 Northern Boulevard
Roslyn, New York 11576
(516) 365-9802
ERF:dm

Enclosures:

- 1) Check in the amount of \$180.00
- 2) Two Information Disclosure Statements of Dr. Staudacher, dated 9/10/03 and 11/12/03
- 2) 2 Forms PTO-1449 form, European Search Report - three & four references respectively

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commission for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 10, 2003


Maria Guastella



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

SCHWAB ET AL-3

Serial Number : 09/764,634

Group Art Unit: 1765

Filed: Jan 18, 2001

For: PROCESS FOR PRODUCING A SEMICONDUCTOR WAFER

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the Japanese Office Action and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

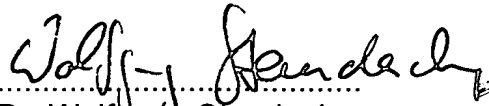
I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

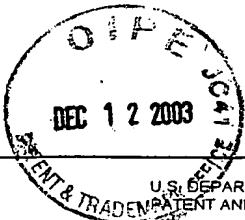
For JP 06-084881 an English Abstract is enclosed.

For JP 03-284844 an English Abstract is enclosed.

For JP 2000-106355 an English Abstract is enclosed.

Signed this 10th day of September, 2003.


.....
Dr. Wolfgang Staudacher

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO. : ST 9943SERIAL NO. 091764634

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT : Schwab et al.FILING DATE: Jan. 18, 2001GROUP: 1765

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL	<u>06-084881</u>	<u>3/25/1994</u>	<u>Japan</u>				
	AM	<u>03-284844</u>	<u>12/16/1991</u>	<u>Japan</u>				
	AN	<u>2000-106355</u>	<u>11/04/2000</u>	<u>Japan</u>				
	AO							
	AP							

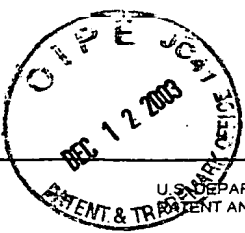
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		<u>English Abstract corresp. to JP 06-084881</u>
	AS		<u>English Abstract corresp. to JP 03-284844</u>
	AT		<u>English Abstract corresp. to JP 2000-106355</u>

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO. : ST 9943SERIAL NO. 09/764,634APPLICANT : Schwab et al 3FILING DATE: Jan. 18, 2001GROUP: 1765

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	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL	<u>198 05 835</u>	<u>8/19/99</u>	<u>Germany</u>				
	AM	<u>0637064</u>	<u>21/1/95</u>	<u>Europe</u>				
	AN							
	AO							
	AP							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		<u>English Derwent Abstract AN 1999-459666</u>
			<u>corresponding to DE 19805835</u>
	AS		
	AT		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.